

<b>Notice of References Cited</b>		Application/Control No.	Applicant(s)/Patent Under Reexamination	
		10/706,735	WEIMER, WAYNE A.	
Examiner		Art Unit		Page 1 of 1
Howard E. Abramowitz		1762		

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	C	US-6,781,690	08-2004	Armstrong et al.	356/301
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	K	US-			
	L	US-			
	M	US-			

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**NON-PATENT DOCUMENTS**

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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.